

EV-S

# THE ENERGY SAVER

EV-S dry vacuum pump for small dimensions and big energy savings



N<sup>2</sup> レギュレータ N<sup>2</sup> REGULATOR

The EV-S has the lowest power consumption in its class. The flexible rotation speed and idle mode make their contribution to save energy. In clean applications no  $\rm N_2$  purge or nitrogen is required.

#### **BENEFITS**

- Significantly reduced energy consumption
- Low operation costs
- High profitability
- Very small footprint



## Ahead > Beyond

| Models *                         |   | EV-S20   | EV-S30   | EV-S50   | EV-S100  | EV-S200  |
|----------------------------------|---|----------|----------|----------|----------|----------|
| Pumping speed in I/min           |   | 1,670    | 3,300    | 5,000    | 10,000   | 20,000   |
| Pumping speed<br>in m³/h         |   | 100      | 198      | 300      | 600      | 1,200    |
| Ultimate pressure<br>Pa/mbar     |   | 5.0/5e-2 | 1.0/1e-2 | 0.5/5e-3 | 0.5/5e-3 | 0.5/5e-3 |
| Power at ultimate pressure in kW |   | 0.4      | 0,4      | 0.55     | 0.65     | 0.75     |
| Cooling water flow I/min         |   | 1.5 - 3  | 1.5 - 3  | 2 - 3    | 2 - 3    | 2 - 3    |
| N2 purge flow Pam³/s             |   |          | 17 - 20  |          |          |          |
| Size in mm                       | L | 537      | 724      | 472      | 532      | 672      |
|                                  | W | 230      | 250      | 230      | 260      | 275      |
|                                  | Н | 274      | 310      | 570      | 570      | 631      |
| Weight in kg                     |   | 60       | 90       | 100      | 120      | 170      |
|                                  |   |          |          |          |          |          |

#### **APPLICATIONS FOR EV-S**

Load lock

Transfer

Etch

CVD

#### **APPLICATIONS RANGE**



#### \* All models are available in "N" and "P" version N = with Nickel alloy P = Nitrogen purge module

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EBARA Precision Machinery Europe (EPME) is part of the Japanese EBARA Group and employs more than 200 people in Europe. The portfolio includes dry and turbo molecular vacuum pumps as well as gas abatement systems. In addition, EPME sells state-of-the-art CMP tools, wafer bevel polishing and substrate coating systems. In Europe, EPME has a central warehouse and two overhaul centres for vacuum pumps. EBARA is No 2 on the vacuum pumps and CMP tools world market and No 1 on the Wafer Bevel Polisher world market.

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